CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with ifficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington,

D.C. 20231, on August 30, 2002.

Pamela L. Patrick

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re U.S. Patent application:

Hisato SHINOHARA et al.

Application Serial No. 08/169,127

Filed: December 20, 1993

For: METHOD AND SYSTEM OF LASER PROCESSING

December 20, 1993

Capplication:

Art Unit: 1762

Capplication:

Capp

SUPPLEMENTAL AMENDMENT

09/11/2002 GGEBREGI 00000055 08169127

Honorable Commissioner of Patents
Washington, D.C. 20231

01 FC:
02 FC:

1584.00 OP

Sir:

In response to the Office Action mailed July 30, 2002, the period for response being one month or August 30, 2002, please amend the above-identified application as follows:

IN THE CLAIMS:

Please amend claims 1, 6, and 11 as follows. The amendments to the claims are outlined in the Attachment to the Amendment using the conventional method of bracketing and underlining.

1. (Twice Amended) A method for treating an object with a laser comprising the steps

emitting a laser beam from the laser;

expanding said laser beam in a first direction so as to increase a first cross-sectional dimension of said laser beam to form an expanded laser beam;

of:

NVA238015.1